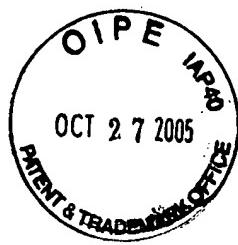


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Docket No.: SON-2612/DIV
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shigeru Fujita

Application No.: 10/785,005

Confirmation No.: 9742

Filed: February 25, 2004

Art Unit: 2814

For: SEMICONDUCTOR DEVICE AND ITS
MANUFACTURING METHOD

Examiner: T. X. Le

REQUEST FOR RECONSIDERATION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated October 4, 2005 (Paper No. 093005), Applicant respectfully requests that the above-identified patent application be reconsidered in view of the remarks that follow, that each of the presently pending claims be allowed, and that the application be passed to issue.

REMARKS

This communication is a full and timely response to the non-final Office Action dated October 4, 2005 (Paper No./Mail Date 093005). Claims 1-5 and 13-16 are pending where claims 1 and 13 are independent.

Rejections Under 35 U.S.C. §102

Claims 1-4 and 13-15 were rejected under 35 U.S.C. §102(e) as anticipated by *Bojarczuk, Jr. et al.*—U.S. Patent Application Publication No. 2002-0190302. Applicant respectfully traverses this rejection.